

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/643,867	<b>Applicant(s)/Patent under Reexamination</b> CHOI, UN-JIN
<b>Examiner</b> William J. Klimowicz	<b>Art Unit</b> 2627	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner